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5/11/99
T. Roots

PATENT
Atty. Dkt. No. AMAT/2966/PDD/KPU1/JW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: §
Rathi et al. §
Serial No.: 09/165,248 § Group Art Unit: 2811
Filed: October 1, 1998 § Examiner: Unknown
For: A Silicon Carbide Deposition For §
Use As A Barrier Layer and An §
Etch Stop §

Assistant Commissioner of Patents
Washington, D.C. 20231

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APR 27 1999

TECHNOLOGY CENTER 2800


Dear Sir:

CERTIFICATE OF MAILING

37 C.F.R. 1.8

I hereby certify that this correspondence is being deposited on April 8, 1999, with the U.S. Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner of Patents, Washington, D.C. 20231.

04/08/1999
Date


D. Brit Nelson

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §§ 1.97 and 1.98 (NO FEE DUE)**

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, the Applicant respectfully requests that this Supplemental Information Disclosure Statement be entered and the references listed on attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed references are enclosed for convenience of the Examiner.

In accordance with 37 C.F.R. § 1.97, this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or an admission that the information cited in the statement is, or is considered to be, material to patentability as defined in § 1.56(b).

Because this Supplemental Information Disclosure Statement is filed before the first Office Action no fee is due.

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Respectfully submitted,



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